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PATENT

Our Case No.7103/261 Lam Ref. No. P0704

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Allan A. Radman	Examiner:
Serial No.: 09/843,323) Group Art Unit:
Filing Date: April 25, 2001))
For: SPHERICAL CAP-SHAPED POLISHING HEAD IN A CHEMICAL MECHANICAL POLISHING APPARATUS FOR SEMICONDUCTOR WAFERS)))

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Pursuant to the obligation under 37 C.F.R. 1.56 and in conformance with 37 C.F.R. 1.97-1.99, Applicant hereby submits references A1-A8 listed on the attached form PTO-1449 for consideration by the Examiner.

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of this Information Disclosure Statement does not constitute an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. Section 1.56(b). Further, Applicant reserves the right to contest the references as prior art against the present application, and Applicant does not believe that the disclosure of these references, even if finally determined to be prior art, anticipate Applicant's invention or that the references make Applicant's invention obvious.

Applicant respectfully requests that the Examiner review the entire disclosure of the RECEIVED documents and make them of record.

Respectfully submitted,

MAR X 7 2002

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Linda D. Kennedy

Registration No. 44,183

Attorney for Applicants

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